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Retraction Note: Flexible Field Emitter for X-ray Generation by Implanting CNTs into Nickel Foil

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The Editors-in-Chief have retracted this article [1] because it significantly overlaps with previously published articles by the same authors [2, 3].

The authors do not agree with this retraction.

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References

1. Sun B, Wang Y, Ding G (2016) Flexible field emitter for X-ray generation by implanting CNTs into nickel foil. Nanoscale Res Lett 11:393 https://doi.org/10.1186/s11671-016-1598-z
2. Sun B, Wang Y, Ding G (2016) Flexible Field Emitter for X-ray Generation by Implanting CNTs into Nickel Foil. Nanoscale Res Lett 11:326 https://doi.org/10.1186/s11671-016-1523-5
3. Sun B, Wang Y, Ding G (2016) Fabrication of a Ni-matrix CNT flexible field emission electron source for X-ray generation by micromachining. Opt Mater Express 6:2304–2312 https://doi.org/10.1364/OME.6.002304

The original article can be found online at https://doi.org/10.1186/s11671-016-1598-z

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